

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 6,830,652 B1
DATED : December 14, 2004
INVENTOR(S) : Tadahiro Ohmi et al.

Page 1 of 1

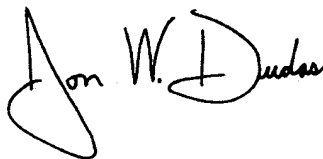
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page,

Item [54], Title, replace "**MICROWAVE PLASMA PROCESSING APPARATUS**"
with -- **PLASMA PROCESSING APPARATUS** --.

Signed and Sealed this

Twenty-fourth Day of May, 2005

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a cursive "Dudas".

JON W. DUDAS
Director of the United States Patent and Trademark Office